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Sheet 1 of 2

Substitute Form PTO-1449 (Modified)

Attorney's Docket No. 05770-095001

Application No. 09/616,810

Form PTO-1449

U.S. Department of Commerce Patent and readernark Office

Information Disclosure Statement

by Applicant (Use several sheets if necessary)

**Applicant** 

LESLIE G. FRITZEMEIER ET AL.

Filing Date July 14, 2000

Group Art Unit

(37 CFR §1.98(b))

**U.S. Patent Documents** Examiner Desig. Patent Filing Date Initial ID) Number Issue Date Patentee Class Subclass If Appropriate Gom AA 6,027,564 02/22/2000 Fritzemeier et al. ΑB AC AD AE AF AG AH ΑI AJ ΑK

	Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Clas	7			slation No
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*	AN	WO 99/16941	04/08/99						
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	AR	Lee et al., "Alternative Buffer Architectures for High Critical Current Density YBCO Superconducting Deposits on Rolling Assisted Biaxially-Textured Substrates," Japanese J. Appl. Phys., vol. 38, L178 (1999)				
<b>\</b>	AS	Paranthaman et al., "Growth of Biaxially Textured RE <sub>2</sub> O <sub>3</sub> Buffer Layers on Rolled-Ni Substrates Using Reactive Evaporation for HTS-Coated Conductors," Superconductor Sci. Tech., vol. 12, 319 (1999)				

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Sheet <u>2</u> of <u>2</u>

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Substitute Form PTO-1449 (Mortified)

U.S. Department of Commerce Patent and Trademark Office Attorney's Docket No. 05770-095001

Application No. 09/616,810

Information Disclosure Statement
by Applicant
(Use several sheets if necessary)

Applicant Leslie G. Fritzemeier et al.

Filing Date July 14, 2000

Group Art Unit

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Information Disclosure Statement by Applicant (Use several sheets if necessary)	Applicant Leslie G. Fritzemeier et a	al.
(37 CFR §1.98(b))	Filing Date July 14, 2000	Group Art Unit

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Attorney's Docket No. Application No. 05776-095001

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U.S. Department of Commerce
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Information Disclosure Statement

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Leslie G. Fritzemeier et al.

**Group Art Unit** 

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Filing Date July 14, 2000

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Sheet <u>2</u> of <u>2</u>

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U.S. Department of Commerce (Modified)

Information Disclosure Statement
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U.S. Department of Commerce Patent of Commerce (Modified)

Attorney's Docket No. (05770-095001 09/616,810

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Leslie G. Fritzemeier et al.

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Sheet 1 of 1

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary)

U.S. Department of Commerce Patent and Trademark Office

Attorney's Docket No. 05770-095001

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Applicant

LESLIE G. FRITZEMEIER ET AL.

Filing Date
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